IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 4391

Toshinori OTA et al.

Date: November 3, 2008

Serial No.: 10/555,855

Group Art Unit: 1753

Filed: November 7, 2005

For:

THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC

SEMICONDUCTOR ELEMENT USING THERMOELECTRIC

SEMICONDUCTOR MATERIAL, THERMOELECTRIC MODULE USING

THERMOELECTRIC SEMICONDUCTOR ELEMENT AND

MANUFACTURING METHOD FOR SAME

VIA EFS WEB

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is an Office Action issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

THIS CORRESPONDENCE IS BEING SUBMITTED ELECTRONICALLY THROUGH THE PATENT AND TRADEMARK OFFICE EFS FILING SYSTEM ON November 3, 2008

Respectfully submitted,

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